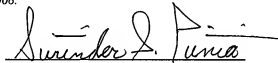


IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant: Senkevich *et al.* **Confirmation No.:** 6502
Serial No.: 10/531,245 **Group Art Unit:** 1722 (per office Action)
1791 (per PAIR)
Filed: April 14, 2005 **Examiner:** Seyed M. Malekzadeh
Title: ATOMIC LAYER DEPOSITION OF NOBLE METALS

CERTIFICATE OF ELECTRONIC SUBMISSION

I certify that this document is being electronically submitted to the United States Patent and Trademark Office on March 27, 2008.



Surinder S. Punia
Agent for Applicant(s)
Registration No. 60,045
Date of Signature: March 27, 2008

Commissioner for Patents
P.O. Box 1450
Alexandria, Virginia 22313-1450
Attn.: Seyed M. Malekzadeh

RESPONSE TO OFFICE ACTION

Dear Sir:

This paper is filed in response to the Office Action mailed on September 27, 2007, in connection with the above-identified U.S. patent application. In light of a petition for a three-month extension and fee therefore, enclosed herewith, the period for response expires on March 27, 2008. This response is timely filed.

Amendments to the Claims are reflected in the listing of claims that begins on page 3 of this paper. **Remarks/Arguments** begin on page 6 of this paper.